

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Noorbakhsh et al.

Serial No.: 09/519,719

Confirmation No.: 8956

Filed:

March 7, 2000

For:

TEMPERATURE CONTROLLED

SEMICONDUCTOR

PROCESSING CHAMBER

LINER

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit: 1763

Examiner:

Luz L. Alejandro

TECHNOLOGY CENTER 1700

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on January 27, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 2023

PETITION FOR ONE-MONTH EXTENSION OF TIME

Applicant respectfully petitions the Commissioner under 37 CFR 1.136(a) to grant a one-month extension of time to and including February 23, 2003, in which to file the Response to Office Action Dated October 23, 2002.

This form is filed in duplicate. The Commissioner is authorized to charge the fee of \$110.00 and any additional fees which may be required for this submission to Deposit Account No. 20-0782/AMAT/4150/BTP.

Respectfully submitted

B. Todd Patterson

Registration No. 37,906

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